

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 5653

Minjuan ZHANG et al.

Docket No. 2001-0712A

Serial No. 09/874,066

Group Art Unit 1762

Filed June 6, 2001

**Examiner Timothy Howard MEEKS** 

METHOD AND SYSTEM FOR FORMING

**COPPER THIN FILM** 

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

## RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents, Washington, D.C. 20231

Sir:

In response to the Restriction Requirement of February 12, 2003, Applicants hereby elect the invention of Group I, claims 1-8, drawn to a method, without traverse, for further prosecution. In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

Minjuan ZHANG et al.

Dowglas Hahm

Registration No. 44,142

Attorney for Applicants

WDH/gtg Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 March 11, 2003